



PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/712,775 Group Art Unit: 1765  
Filing Date: November 14, 2003 Examiner: Anita K. Alanko  
Applicant: Donggyun Han et al.  
Title: APPARATUS AND METHOD FOR REMOVING  
PHOTORESIST FROM A SUBSTRATE  
Attorney Docket: 2557-000216/US

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314  
**Mail Stop Amendment**

July 17, 2006

**AMENDMENT**

Sir:

In response to the Office Action mailed March 17, 2006, the due date having been extended one (1) month to July 17, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** begin on page 2 of this Amendment.

**Remarks** begin on page 8 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	40	-	50	=	0
Independent	3	-	4	=	0

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